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App. No. 09/554,629
Amendment dated September 3, 2003
Reply to Office Action of March 3, 2003

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Attorney Docket No. 00336/LH

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant : Shinji NAKAHARA, et al.

Serial No. : ~~09/544,629~~

09/554 629

Filed : October 11, 2000

For : DEVICE FOR HOLDING
SEMICONDUCTOR WAFER

Art Unit : 1763

Examiner : Ram N. Kackar

Confirm. No.: 6434

Customer No.: 01933

AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE - GROUP 1700

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Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

S I R :

Responsive to the Office Action mailed March 3, 2003, the term for response to which is extended by three months by Petition filed concurrently herewith to September 3, 2003, please amend the present application under the provisions of 37 C.F.R. 1.116 as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

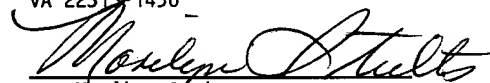
Remarks/Arguments begin on page 5 of this paper.

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Marilyn Skults

In the event that this Paper is late filed, and the necessary petition for extension of time is not filed concurrently herewith, please consider this as a Petition for the requisite extension of time, and to the extent not tendered by check attached hereto, authorization to charge the extension fee, or any other fee required in connection with this Paper, to Account No. 06-1378.